The listing of claims will replace all prior versions, and listings, of claims in the application:

## **Listing of Claims:**

- 1. (Currently Amended) A bootstrap circuit comprising a thin film transistor wherein:
- a channel forming region of the thin film transistor comprising comprises a polycrystalline semiconductor, and

the thin film transistor is a depletion mode transistor.

- 2. (Original) The bootstrap circuit according to claim 1, wherein the thin film transistor is directly connected to an output terminal.
- 3. (Original) The bootstrap circuit according to claim 1, wherein the polycrystalline semiconductor film is provided over either a quartz substrate or a glass substrate.
  - 4. (Original) A bootstrap circuit comprising a thin film transistor wherein:
- a channel forming region of the thin film transistor comprises a polycrystalline semiconductor which is formed by crystallizing an amorphous silicon, and the thin film transistor is a depletion mode transistor.
  - 5. (Original) The bootstrap circuit according to claim 4, wherein the thin film transistor is directly connected to an output terminal.
  - 6. (Original) The bootstrap circuit according to claim 4,

wherein the polycrystalline semiconductor film is provided over either a quartz substrate or a glass substrate.

- 7. (Currently Amended) A driver circuit comprising:
- a shift register;
- a buffer circuit electrically connected to the [[sift]] shift register, comprising a source follower circuit comprising a thin film transistor; and

an analog memory electrically connected to the buffer circuit,

wherein:

a channel forming region of the thin film transistor comprises a polycrystalline semiconductor, and

the thin film transistor is a depletion mode transistor.

- 8. (Original) The driver circuit according to claim 7, wherein the thin film transistor is directly connected to an output terminal.
- 9. (Original) The driver circuit according to claim 7, wherein the polycrystalline semiconductor film is provided over either a quartz substrate or a glass substrate.
  - 10. (Currently Amended) A driver circuit comprising:
  - a shift register;
- a buffer circuit electrically connected to the [[sift]] shift register, comprising a source follower circuit comprising a thin film transistor; and

an analog memory electrically connected to the buffer circuit,

wherein:

a channel forming region of the thin film transistor comprises a polycrystalline semiconductor which is formed by crystallizing an amorphous silicon, and

the thin film transistor is a depletion mode transistor.

- 11. (Original) The driver circuit according to claim 10, wherein the thin film transistor is directly connected to an output terminal.
- 12. (Original) The driver circuit according to claim 10, wherein the polycrystalline semiconductor film is provided over either a quartz substrate or a glass substrate.
  - 13. (Currently Amended) A driver circuit comprising: a shift register;
- a buffer circuit electrically connected to the [[sift]] shift register, comprising a bootstrap circuit comprising a thin film transistor; and

an analog memory electrically connected to the buffer circuit, wherein:

a channel forming region of the thin film transistor comprises a polycrystalline semiconductor, and

the thin film transistor is a depletion mode transistor.

- 14. (Original) The driver circuit according to claim 13, wherein the thin film transistor is directly connected to an output terminal.
- 15. (Original) The driver circuit according to claim 13, wherein the polycrystalline semiconductor film is provided over either a quartz substrate or a glass substrate.
  - 16. (Currently Amended) A driver circuit comprising: a shift register;

a buffer circuit electrically connected to the [[sift]] <u>shift</u> register, comprising a bootstrap circuit comprising a thin film transistor; and

an analog memory electrically connected to the buffer circuit, wherein:

a channel forming region of the thin film transistor comprises a polycrystalline semiconductor which is formed by crystallizing an amorphous silicon, and the thin film transistor is a depletion mode transistor.

- 17. (Original) The driver circuit according to claim 16, wherein the thin film transistor is directly connected to an output terminal.
- 18. (Original) The driver circuit according to claim 16, wherein the polycrystalline semiconductor film is provided over either a quartz substrate or a glass substrate.
  - 19. (Currently Amended) A display device comprising:
  - an insulating surface;
  - a signal line over the insulating surface;
  - a scanning line over the insulating surface;
- a pixel electrically connecting connected to the signal line and the scanning line; and
- a driver circuit electrically connecting connected to the scanning line, comprising:
  - a shift register;
- a buffer circuit electrically connected to the [[sift]] shift register, comprising a bootstrap circuit comprising a thin film transistor; and

an analog memory electrically connected to the buffer circuit, wherein:

a channel forming region of the thin film transistor comprises a polycrystalline semiconductor, and

the thin film transistor is a depletion mode transistor.

- 20. (Original) The display device according to claim 19, wherein the thin film transistor is directly connected to an output terminal.
- 21. (Original) The display device according to claim 19, wherein the polycrystalline semiconductor film is provided over either a quartz substrate or a glass substrate.
  - 22. (Currently Amended) A display device comprising:
  - an insulating surface;
  - a signal line over the insulating surface;
  - a scanning line over the insulating surface;
- a pixel electrically connecting connected to the signal line and the scanning line; and
- a driver circuit electrically connecting connected to the scanning line, comprising:
  - a shift register;

wherein:

- a buffer circuit electrically connected to the [[sift]] shift register, comprising a bootstrap circuit comprising a thin film transistor; and
  - an analog memory electrically connected to the buffer circuit,
- a channel forming region of the thin film transistor comprises a polycrystalline semiconductor which is formed by crystallizing an amorphous silicon, and the thin film transistor is a depletion mode transistor.

- 23. (Original) The display device according to claim 22, wherein the thin film transistor is directly connected to an output terminal.
- 24. (Original) The display device according to claim 22, wherein the polycrystalline semiconductor film is provided over either a quartz substrate or a glass substrate.